

Notice of References Cited	Application/Control No. 09/905,157	Applicant(s)/Patent Under Reexamination LEWIS ET AL.	
	Examiner Erik Kielin	Art Unit 2813	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Bansal et al. "Alkylation of Si surfaces using a two-step halogenation/Grignard route" Journal of the American Chemical Society, Vol. 118, 1996, pp. 7225-7226.
	V	
	W	
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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